

APPLICATION No.  
09/933,819

FILING DATE  
August 22, 2001

GROUP  
2121

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OCT 07 2002  
PATENT & TRADEMARK OFFICE

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Examiner Initials	Foreign Patent Document		Country	Date of Publication (MM-DD-YYYY)	Translation	
	Number	Kind Code (if known)			Yes	no
TM	2 225 881	A	Great Britain	06-13-1990		
TM	0 588 341	A2	EPO	03-23-1994		
TM	95/19006		WIPO	07-13-1995		
TM	01/44964	A2	WIPO	06-21-2001		
TM	2 230 119	A	Great Britain	10-10-1990		
TM	0 671 685	A2	EPO	09-13-1995		
TM	0 628 917	A2	EPO	06-09-1994		

Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	<del>U.S. Patent Application No. 10/175,446 "DATA PROCESSING SYSTEM AND CONTROL METHOD"</del>		
	<del>U.S. Patent Application No. 10/175,447 "DATA PROCESSING SYSTEM AND CONTROL METHOD"</del>		
	<del>U.S. Patent Application No. 10/174,750 "DATA PROCESSING SYSTEM AND CONTROL METHOD"</del>		
Examiner Signature	<i>Tina Mearns</i>	Date Considered	<i>June 3, 2004</i>

(05/01)



SHEET 1 OF 1

Substitute for forms 1449A/PTO &amp; 1449B/PTO

THIRD INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

ATTORNEY'S DKT NO.

032865-012

APPLICATION NO.

09/933,819

APPLICANT

Shoichi KAMANO et al.

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U.S. PATENT DOCUMENTS				
Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)
TM	5,450,553		Kitagaki et al.	09-12-1995
TM	5,487,173		Greiss et al.	01-23-1996
TM	5,903,744		Tseng et al.	05-11-1999
TM	5,495,558		Gibart et al.	02-27-1996
TM	5,894,582		Yoshida et al.	04-13-1999
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				MAR 17 2003
				Technology Center 2100

FOREIGN PATENT DOCUMENTS					
Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	Translation Yes No
TM	2000-112585		Japan	04-21-2000	X
TM	2 232 514	A	Great Britain	12-12-1990	
TM	0 174 231	A1	EPO	03-12-1986	

NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	U.S. Patent Application No. 10/320,622 "DATA PROCESSING SYSTEM"
	U.S. Patent Application No. 10/109,650 "DATA PROCESSING SYSTEM AND DESIGN SYSTEM"

Examiner Signature

*Denise M. Menzies*

Date

Considered

*June 3, 2004*

EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

Substitute for form 1449A/PTO

ATTORNEY'S DKT NO.  
032865-012

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# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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## U.S. PATENT DOCUMENTS

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# FOREIGN PATENT DOCUMENTS

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**NONPATENT LITERATURE DOCUMENTS**

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	<del>U.S. Patent Application No. 09/860,563</del>		
	<del>U.S. Patent Application No. 09/985,987</del>		
	<del>U.S. Patent Application No. 10/053,737</del>		
Examiner Signature	<i>Tonia M. Merske</i>	Date Considered	<i>June 3, 2004</i>

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